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## BIB DATA SHEET

CONFIRMATION NO. 7802

<b>SERIAL NUMBER</b> 10/529,891	<b>FILING or 371(c) DATE</b> 07/26/2005 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1795	<b>ATTORNEY DOCKET NO.</b> 00684.003654		
<b>APPLICANTS</b> Takako Yamaguchi, Atsugi-shi, JAPAN; Yasuhisa Inao, Kanagawa-ken, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/09375 06/25/2004 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-182041 06/26/2003 JAPAN 2004-097699 03/30/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /JONATHAN G JELSMAN/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 7	<b>TOTAL CLAIMS</b> 14	<b>INDEPENDENT CLAIMS</b> 7
<b>ADDRESS</b> FITZPATRICK CELLA HARPER & SCINTO 30 ROCKEFELLER PLAZA NEW YORK, NY 10112 UNITED STATES						
<b>TITLE</b> Exposure mask, method of designing and manufacturing the same, exposure method and apparatus, pattern forming method, and device manufacturing method						
<b>FILING FEE RECEIVED</b> 2640	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			